



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE
INFORMATION DISCLOSURE STATEMENT

APPLICANT(S): T. Kobayashi, et al. DOCKET NO.: 09794353-0033
SERIAL NO.: 10/813,528 GROUP ART UNIT: 2812
DATE FILED: March 30, 2004 EXAMINER: S. Mulpuri
INVENTION: "METHOD FOR PRODUCING STRUCTURED SUBSTRATE,
STRUCTURED SUBSTRATE, METHOD FOR PRODUCING
SEMICONDUCTOR LIGHT EMITTING DEVICE,
SEMICONDUCTOR LIGHT EMITTING DEVICE, METHOD FOR
PRODUCING SEMICONDUCTOR DEVICE, SEMICONDUCTOR
DEVICE, METHOD FOR PRODUCING DEVICE, AND DEVICE"

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

SIR:

In accordance with the provisions of 37 C.F.R. § 1.56, Applicants request that citation and examination of the references identified on the attached PTO-1449 form, copies of which are enclosed herewith in accordance with 37 C.F.R. §1.98, be made during the course of examination of the above-referenced application for United States Letters Patent.

I. SUBMITTED US PATENT REFERENCES

	<u>Number</u>	<u>Inventor(s)</u>	<u>Date of Publication</u>
AA	6,015,979	Sugiura, et al.	January 18, 2000
AB	2001/0038655	Tanaka, et al.	November 8, 2001

II. SUBMITTED FOREIGN PATENT REFERENCES

	<u>Number</u>	<u>Country</u>	<u>Date of Publication</u>
AH	JP2000-21789	Japan	January 21, 2000
AI	JP2002-33512	Japan	January 31, 2002
AJ	JP2003-78214	Japan	March 14, 2003
AK	JP2000-164929	Japan	June 16, 2000
AL	JP2001-257193	Japan	September 21, 2001

AM	JP2000-353669	Japan	December 19, 2000
AN	JP11-103135	Japan	April 13, 1999
AO	JP11-238687	Japan	August 31, 1999
AP	JP11-195813	Japan	July 21, 1999
AQ	EP 1 005 068 A2	Europe	May 31, 2000
AR	EP 1 088 914 A1	Europe	April 4, 2001

III. OTHER ITEMS OF INFORMATION

IV. EXPLANATION OF RELEVANCE

The above-identified references are submitted as being relevant to the subject matter of the above-identified application.

Submitted by,


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37 CFR 1.501
INFORMATION DISCLOSURE STATEMENT
IN A PATENT
(use several sheets if necessary)

Docket No.
09794353-0033Serial No.
10/813,528Applicants:
T. Kobayashi, et al.Filing Date
March 30, 2004Group Art Unit
2812**U.S. PATENT DOCUMENTS**

Examiner's Initials		Document Number	Date	Name	Class	Subclass	Filing Date If appropriate
	AA	6,015,979	1-18-00	Sugiura, et al.			
	AB	2001/0038655	11-8-01	Tanaka, et al.			
	AC						
	AD						
	AE						
	AF						
	AG						

FOREIGN PATENT DOCUMENTS

		Document Number	Date	Country	Class	Subclass	Translation	
							Yes	No
	AH	JP2000-21789	1-21-00	Japan			Abstract	
	AI	JP2002-33512	1-31-02	Japan			Abstract	
	AJ	JP2003-78214	3-14-03	Japan			Abstract	
	AK	JP2000-164929	6-16-00	Japan			Abstract	
	AL	JP2001-257193	9-21-01	Japan			Abstract	
	AM	JP2000-353669	12-19-00	Japan			Abstract	
	AN	JP11-103135	4-13-99	Japan			Abstract	
	AO	JP11-238687	8-31-99	Japan			Abstract	
	AP	JP11-195813	7-21-99	Japan			Abstract	
	AQ	EP 1 005 068 A2	5-31-00	Europe				
	AR	EP 1 088 914 A1	4-4-01	Europe				
	AS							
	AT							

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

AU	
AV	
AW	
AX	
AY	
AZ	

Examiner _____ Date Considered _____

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.